

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|------------------------|--------------------------|
| In re application of | Docket No: Q79703 |
| Hisayuki MIKI, et al. | Allowed: May 19, 2009 |
| Appln. No.: 10/586,849 | Group Art Unit: 2814 |
| Confirmation No.: 3462 | Examiner: Wai Sing LOUIE |
| Filed: July 20, 2006 | |

For: GALLIUM NITRIDE-BASED COMPOUND SEMICONDUCTOR MULTILAYER
STRUCTURE AND PRODUCTION METHOD THEREOF

AMENDMENT UNDER 37 C.F.R. §1.312

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 C.F.R. §1.312, please amend the above-identified
application as follows on the accompanying pages.

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